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## BIB DATA SHEET

CONFIRMATION NO. 6202

<b>SERIAL NUMBER</b> 10/595,762	<b>FILING or 371(c) DATE</b> 07/13/2006 <b>RULE</b>	<b>CLASS</b> 360	<b>GROUP ART UNIT</b> 1795	<b>ATTORNEY DOCKET NO.</b> SC12991CF	
<b>APPLICANTS</b> Kyle Patterson, Froges, FRANCE; Kirk Strozewski, Round Rock, TX; <b>** CONTINUING DATA *****</b> This application is a 371 of PCT/EP05/01511 02/15/2005 <b>** FOREIGN APPLICATIONS *****</b> EUROPEAN PATENT OFFICE (EPO) 04290429.2 02/17/2004 <b>** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **</b> 03/21/2008					
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and /CONNIE P JOHNSON/ Acknowledged Examiner's Signature	<input type="checkbox"/> Met after Allowance Initials	<b>STATE OR COUNTRY</b> FRANCE	<b>SHEETS DRAWINGS</b> 2	<b>TOTAL CLAIMS</b> 10	<b>INDEPENDENT CLAIMS</b> 2
<b>ADDRESS</b> FREESCALE SEMICONDUCTOR, INC. LAW DEPARTMENT 7700 WEST PARMER LANE MD:TX32/PL02 AUSTIN, TX 78729 UNITED STATES					
<b>TITLE</b> Immersion Lithography Technique And Product Using A Protection Layer Covering The Resist					
<b>FILING FEE RECEIVED</b> 1030	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		